

**MARK YOUR CALENDAR FOR
THE NEXT HOT SPOT...**

**10TH ANNUAL EUROPEAN
ADVANCED EQUIPMENT CONTROL
ADVANCED PROCESS CONTROL
CONFERENCE**



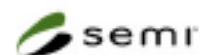
*Hotel Sheraton, Catania
Sicily – Italy*

April 22 - 24, 2009

*The annual European gathering of leaders
in the semiconductor manufacturing industry*

ORGANISATION AND CONTACTS

The 10th European AEC/APC Conference in April 2009 is jointly organized by:



Exhibitors and Sponsors are welcome

CONTACT



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TOPICS:

- Equipment and Process Fault Detection, Classification, and Prediction
- Data Management and process control
- Metrology and Analytics
- Fab-wide APC, Yield and “Multi-fab” Approaches, e-Diagnostics and e-Manufacturing
- Standards and Roadmaps
- Academia contributions, Future Needs and Opportunities

Important Dates

Abstract Submission Deadline: January 05, 2009
Notification of Acceptance: February 05, 2009
Presentation Due: March 13, 2009